



RECEIPT #5/100  
S. Coates  
6-25-99  
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of

Eric H. Lenz

Application No.: 09/105,547

Filed: June 26, 1998

For: FOCUS RING ARRANGEMENT FOR  
SUBSTANTIALLY ELIMINATING  
UNCONFINED PLASMA IN A PLASMA  
PROCESSING CHAMBER

Examiner: Unassigned

Art Unit: 2817

August 24, 1998

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, DC 20231 on August 24, 1998.

Signed: Sharon D. Coleman

Sharon D. Coleman

REQUEST FOR CORRECTED FILING RECEIPT

Assistant Commissioner for Patents

**Box: Patents**

Washington, D.C. 20231

Sir:

Enclosed is a copy of the Filing Receipt for the above-identified patent application. Please reprint the Filing Receipt as follows and mail the corrected copy to the undersigned.

Change the Title "FOCUS ARRANGEMENT FOR SUBSTANTIALLY ELIMINATING UNCONFINED PLASMA IN A PLASMA PROCESSING CHAMBER" to --FOCUS RING ARRANGEMENT FOR SUBSTANTIALLY ELIMINATING UNCONFINED PLASMA IN A PLASMA PROCESSING CHAMBER--.

Since this is a Patent Office typographical error, no fee should be due. However, the Commissioner is authorized to charge any fees that may be due to Deposit Account 50-0388 (Order No.: LAM1P089).

Respectfully submitted,  
BEYER & WEAVER, LLP

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Attorney Docket No.: LAM1P089/P0399

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FILING RECEIPT



RECEIVED JUL 27 1998  
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APPLICATION NUMBER & FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTORNEY DOCKET NO.	DRWGS	TOT CL	IND CL
09/105,547 06/26/98	2817	\$0.00	P0399/LAM1P0	4	22	3

JOSEPH A NGUYEN  
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Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Application Processing Division's Customer Correction Branch within 10 days of receipt. Please provide a copy of the Filing Receipt with the changes noted thereon.

Applicant(s)

ERIC H. LENZ.

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TITLE <sup>RING</sup>

FOCUS ARRANGEMENT FOR SUBSTANTIALLY ELIMINATING UNCONFINED PLASMA  
IN A PLASMA PROCESSING CHAMBER

PRELIMINARY CLASS: 315

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BEYER & WEAVER, LLP

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